In re Application of:

Docket No. 03500.010530.5

KIYOFUMI SAKAGUCHI, ET AKATA TRAS

Application No.: 10/085,046

Filed: March 1, 2002

Examiner:

Group Art Unit: 2813

For: PROCESS FOR PRODUCTION OF

SEMICONDUCTOR SUBSTRATE

Date: July 28, 2003

Mail Stop Interference Director of the U.S. Patent and Trademark Office P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED								
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	159	MINUS	142	= 17	x \$9 \$18	\$306.00		
INDEP. CLAIMS	33	MINUS	25	= 8	x \$42 \$84	\$672.00		
Fee for Multiple Dependent claims \$140°/\$280								
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$978.00		

	Verified Statement claiming small entity status is enclosed, if not filed previously.
X	A check in the amount of \$978.00 is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under

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37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

A check in the amount of \$_______ to cover the fee for a _______ month extension is enclosed.

A check in the amount of \$______ to cover the Information Disclosure Statement fee is enclosed.

X Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 30051

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Form #120

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)			
KIYOFUMI SAKAGUCHI, ET AL.		:	Examiner:		
Application Serial No.: 10/085,046		;	Group Art United: 2813	-	
Filed: March 1, 2002		;)			
For:	PROCESS FOR PRODUCTION OF SEMICONDUCTOR SUBSTRATE) :)			
		:	July 28, 2003	J CK 2300	

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FOURTH PRELIMINARY AMENDMENT

Sir:

Prior to action on the merits, please further amend the above-identified application as follows:

IN THE CLAIMS:

Please add new claims 143-159, as follows:

143. (New) A method for making a thin film semi-conductor comprising the steps

of:

providing a semi-conductor substrate having a surface;